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In re Application of:	\ \frac{1}{2}
Tadahiro OHMI, et al.	JUL 1 8 2002
	was and

Docket No. 00862.021870

Application No.: 09/531,958

Examiner: A. Rodriguez

Filed: March 21, 2000

Group Art Unit: 2828

For: LASER OSCILLATING APPARATUS, EXPOSURE APPARATUS, AND DEVICE

July 18, 2002

**FABRICATION METHOD** 

Commissioner for Patents Washington, D.C. 20231

Sir:

Transmitted herewith is an Supplemental Amendment in the above-identified application.

X No additional fee is required.

The fee has been calculated as shown below

CLAIMS AS AMENDED						
	(2) CLAIMS REMAINING AFTER AMENDMENT		(4) HIGHEST NO. PREVIOUSLY PAID FOR	(5) PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL CLAIMS	21	MINUS	21	= 0	x \$9 \$18	\$ 0.00
INDEP. CLAIMS	6	MINUS	6	= 0	x \$42 \$84	\$ 0.00
Fee for Multiple Dependent claims \$140°/\$280					\$ 0.00	
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT					\$ 0.00	

°Verified Statement claiming	g small ent	tity status i	is enclosed,	if not filed	l previously	y.

A check in the amount of \$\_\_\_\_ is enclosed.

	Charge \$ to Deposit Account No. 06-1205. A duplicate copy of this sheet is enclosed.			
X	Any prior general authorization to charge an issue fee under 37 C.F.R. 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate copy of this paper is enclosed.			
	A check in the amount of \$ to cover the fee for a month extension is enclosed.			
	A check in the amount of \$ to cover the Information Disclosure Statement fee is enclosed.			
X	Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.			
	Respectfully submitted,			
	Mun Kondond			

Attorney for Applicants Michael E. Kondoudis Registration No. 42,758

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00862.021870

## PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

in re F	Application of:	)	
Tadah	iro OHMI, et al.	:	Examiner: A. Rodriguez
Applio	cation No.: 09/531,958	:	Group Art Unit: 2828
Filed:	March 21, 2000	: )	
For:	LASER OSCILLATING APPARATUS, EXPOSURE	· ) :	July 18, 2002

Commissioner for Patents Washington, D.C. 20231

APPARATUS, AND DEVICE FABRICATION METHOD

JUL 19 2002

## SUPPLEMENTAL AMENDMENT

Sir:

Further to the Amendment and Petition for Extension of Time filed July 15, 2002, please amend the above-identified application as follows:

## IN THE SPECIFICATION:

Please substitute the paragraph starting at page 1, line 17 and ending at line 24, with the following paragraph. A marked-up copy of the paragraph, showing the changes made thereto, is attached.

--Recently, a so-called excimer laser has attracted attention as the only highoutput laser that oscillates in the ultraviolet region, and a wide range of applications of the excimer laser can be expected in the electronic industry, chemical industry, energy industry

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